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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 08/581,992 )  
Filed: 1/02/96 ) Group Art Unit: 3624 19  
Applicants: Frank J. Pellegrino ) H. Kazimi  
              Robert W. Fletcher )  
Entitled: Method for Determining ) RECEIVED  
              The Risk Associated With ) OCT 08 2003  
              Licensing Or Enforcing )  
              Intellectual Property )  
              )

H. Kazimi  
**RECEIVED**

OCT 08 2003

Technology Center 2100

October 2, 2003

COMMISSIONER OF PATENTS & TRADEMARKS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL LETTER**

Dear Sir:

Please find enclosed an Amendment vis-à-vis the above identified Application.

Respectfully submitted,



Attorney for the Applicant  
Robert W. Fletcher, Reg. No. 25,334  
10503 Timberwood Circle, Suite 114  
Louisville, KY 40223  
(502) 429-8007; Fax (502) 429-0994

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OCT 15 2003  
**GROUP 3600**

**CERTIFICATE OF MAILING**

I hereby certify that this Amendment for US Serial No. 08/581,992 file 1/2/96;  
Entitled: Method for Determining The Risk Associate with Licensing or Enforcing  
Intellectual Property is being deposited with the United States Postal Service with first  
class postage thereon in an envelope addressed to Commissioner of Patents and  
Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450 on October 2, 2003.

  
Attorney for the Applicant  
Robert W. Fletcher, Reg. No. 25,334



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Group Art Unit:  
2763

Examiner:

H. Kazimi

*Kazimi  
10/13/03*

October 2, 2003

COMMISSIONER OF PATENTS & TRADEMARKS  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the office action dated July 2, 2003 the applicant has the following response:

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